HEWLETT-PACKARD COMPANY Intellectual Property Administration P. O. Box 272400 Fort Collins, Colorado 80527-2400

PATENT APPLICATION

ATTORNEY DOCKET NO. 200311972-1

IN THE

UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s):

Curt Nelson et al

Confirmation No.: 1930

oplication No.: 10/80 €341

Examiner: Asok Sarkar

Filing Date:

Mar 12, 2004

Group Art Unit:

2891

Title:

Method And/Or System For Forming A Thin Film

Mail Stop Commissioner for Patents PO Box 1450 Alexandria, VA 22313-1450

TRANSMITTAL LETTER FOR RESPONSE/AMENDMENT

Sir:							
Trar	nsmitted herewith is/are the following in the above-io	dentified	app	olication:			
()	Response/Amendment	()	Petition to extend time to respond			
()	New fee as calculated below	()	Supplemental Declaration			
(X)	No additional fee						
(X)	Other: Response to Restriction Requirement	(fee \$					

		CLA	MS A	SAME	NDED	BY OT	HER THAN A	SMAL	ENTIT	Υ			
(1) FOR		(2) AIMS REMAINING TER AMENDMENT		(3) (4) JMBER HIGHEST NUMBER EXTRA PREVIOUSLY PAID FOR			(5) PRESENT EXTRA		(6) RATE		(7) ADDITIONAL FEES		
TOTAL CLAIMS			МІ	INUS				=	0	×	\$50	\$	0
INDEP. CLAIMS			МІ	INUS				=	0	х	\$200	\$	0
[] FIRST PRESENTATION OF A MULTIPLE DEPENDENT CLAIM + \$360 \$											0		
EXTENSION FEE	N	1ST MONTH \$120.00			MONT 0.00	TH 3RD MON \$1020.0				H MONTH 1590.00		\$	0
OTHER FEES											RFEES	\$	
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT											DMENT	\$	0

to Deposit Account 08-2025. At any time during the pendency of this 0 application, please charge any fees required or credit any overpayment to Deposit Account 08-2025 pursuant to 37 CFR 1.25. Additionally please charge any fees to Deposit Account 08-2025 under 37 CFR 1.16 through 1.21 inclusive, and any other sections in Title 37 of the Code of Federal Regulations that may regulate fees. A duplicate copy of this sheet is enclosed.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, Alexandria, VA 22313-1450.

Date of Deposit: Aug 24, 2005

Typed Name: **Donald J. Coulman**

Signature: 1

Respectfully submitted,

Curt Nelson et al

By &

Donald J. Coulman

Attorney/Agent for Applicant(s)

Reg. No. 50, 406

Date: Aug 24, 2005

Telephone No.: (541) 715-1694

HEWLETT-PACKARD COMPANY Legal Department, IPA Section, ms: 35. P O BOX 272400 3404 East Harmony Road Fort Collins, CO 80528-9599

Attorney Docket No: 200311972-1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

nventors:

Curt Nelson et al.

Examiner: Asok Sarkar

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03/12/2004

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COMMISSIONER FOR PATENTS PO Box 1450 Alexandria, VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT

Dear Sir:

In response to Examiner's Office Communication dated August 11, 2005 Applicant responds as follows:

Examiner has identified two distinct inventions:

- I. Claims 1-31 drawn to a method of forming a thin film, classified in class 438, subclass 795.
- II. Claims 32-51 drawn to a laser annealing system, classified in class 65, subclass 117.

Applicant hereby elects Group I, Claims 1-31 in class 438, subclass 795 without traverse.

Hewlett-Packard Company 1000 NE Circle Blvd. m/s 422B Corvallis, OR 97330 (541) 715-1694

Respectfully submitted, Curt Nelson et al.

Donald J. Wulman

Reg. No. 50,406

Attorney for Applicant

Date: 8-24-05